

Polymerization Photoinitiators with Near-Resonance Enhanced Two-Photon Absorption Cross-Section: Towards High-Resolution Photoresists with Improved Sensitivity

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ABSTRACT: We take advantage of the near-resonant enhancement of the third-order nonlinear response to engineer a two-photon polymerization photoinitiator with optimized efficiency in regard with literature benchmarks. We study in detail its linear and resonant third-order nonlinear optical properties, with a particular focus on photoinduced radical generation. Careful choice of peripheral substituents enable its direct solubilization into a mixture of commercial multifunctional acrylic monomers, resulting in homogeneous photoresist with good optical transparency upon simple mixing. When submitted to sub-nanosecond pulsed laser irradiation at 532 nm, the resulting photoresist displays a polymerization threshold up to eight times lower than that obtained with classically used two-photon initiators, giving rise to sub-100 nm linewidth at 250 nm interline separation, and resulting in highly defined three-dimensional (3D) structures.

INTRODUCTION

Within the last decade, the additive bulk manufacturing of 3D structures has become a major driving force in modern industry and is generally considered as one of the nine pillars of the so-called “4th industrial revolution”, or industry 4.0.¹⁻²

Once limited to rapid prototyping of industrial high-value components and models, nowadays 3D printing has indeed become a relatively standard and affordable technology that is used in the manufacturing of many daily-life goods from plastic housing-shell to medical prostheses.³⁻

⁵ In the near future, 3D printing, owing to its unlimited design flexibility, is expected to substitute polymer thermoforming or milling in high-tonnage productions such as automotive and aerospace industries or the construction sector.⁶⁻⁸

As the range of applications that additive 3D manufacturing encompasses constantly expands, more and more demanding specific technical requirements and constraints tend to emerge.⁹⁻¹⁰ In particular, fabrication of nano and micro-structured objects require resolution that are not accessible with standard layer-by-layer photolithography.¹¹⁻¹³ In that framework two-photon absorption-induced stereolithography is generally considered as a potential way

to circumvent the limitations in achievable spatial resolution.¹⁴⁻¹⁵ However, the intrinsic characteristics of two-photon absorption, which allows localized polymerization reaction in the volume of the focal point of the laser beam, makes it very difficult to extend the polymerization to the fabrication of large structures with such high resolution.¹⁶⁻¹⁷

As a matter of fact, to become more than a “laboratory curiosity”, two-photon additive manufacturing needs to face the challenge of high-throughput, large area printing of surfaces.¹⁷⁻²⁴ To this end, endeavors are focused on the optimization of both optical setups^{16, 25-26} and photoresist sensitivity.

From a chemical point of view, the design of an improved photoresist relies on a combination of a reactive monomer with high functionality, capable of generating an intricate polymer network even at low monomer conversion,²⁷ and a highly sensitive photoinitiator (PI).²⁸ Monomer sensitivity can be improved by removing inhibiting species such as molecular oxygen or exogenous inhibitors (such as MEHQ) generally included as stabilizers in monomer formulations.²⁹ However, such strategies can severely impair the accessible resolution, as they favor radical diffusion outside of the irradiated volume, and result in a loss of control on voxel volume.³⁰⁻³¹ Therefore, a majority of research works have been focused on improving PI efficiency.³²⁻³⁴

As a general statement, PI efficiency essentially relies on two parameters, namely i/ the two-photon absorption cross-section (σ_{TPA}), which quantifies the probability for the chromophore to undergo transition to its excited state upon laser irradiation through the simultaneous absorption of two photons, ii/ the radical generation quantum efficiency, which represents the probability for the excited molecule to generate a radical capable of initiating the reaction of polymerization.³⁵

While a lot of recent researches have focused on the use of PIs with optimized radical generation quantum efficiency,^{34, 36-41} the improvement of σ_{TPA} has exclusively been addressed through a relatively classical chromophore engineering.⁴²⁻⁵⁰ This followed the Equation 1 that approximates in the so-called “three-level model” the imaginary part of the third-order hyperpolarizability γ , responsible for the two-photon absorption phenomenon, where \mathbf{P} denotes a permutation operator over the optical frequencies; μ_{ij} , the transition dipole moment between the singlet state i and the singlet state j ; E_{ij} , the transition energy; $\Delta\mu_{ij}$, the dipole moment difference between the i and j states and Γ the associated damping factor; $\hbar\omega$, energy of the incident photon.

In all of these works, a general paradigm is that dipolar PIs should be selected so that their one-photon absorption (OPA) resonance wavelength lies closely to half of that of the operating laser.⁵¹ By doing so, the sum of the energies of two incident photons is resonant with the energy gap between the ground and excited states of the PI (ie the S_1 state in the case of a dipole, and the S_2 state in the case of a quadrupole). Regarding the lowest TPA energy transition, this strategy leads to a minimization of the second term of the denominator for the D (dipolar molecules) or T (quadrupolar molecules) terms, thus to a maximization of the γ term.⁵²

$$\text{Im}\gamma(-\omega; \omega, -\omega, \omega) = \text{Im} \mathbf{P} \left[\begin{aligned} &+ \frac{\mu_{01}^2 \Delta\mu_{01}^2}{(E_{01} - \hbar\omega - i\Gamma)^2 (E_{01} - 2\hbar\omega - i\Gamma)} (D) \\ &+ \frac{\mu_{01}^2 \mu_{12}^2}{(E_{01} - \hbar\omega - i\Gamma)^2 (E_{02} - 2\hbar\omega - i\Gamma)} (T) \\ &- \frac{\mu_{01}^4}{(E_{01} - \hbar\omega - i\Gamma)^2 (E_{01} + \hbar\omega + i\Gamma)} (N) \end{aligned} \right] \quad (1)$$

However, another way of maximizing γ consists in minimizing the denominator terms by using an incident photon that comes close to the OPA resonance $\hbar\omega \approx E_{01}$ yet does not overlap with the linear absorption band

This phenomenon is known as the near-resonance enhancement of the σ_{TPA} ,⁵³⁻⁵⁵ and has been shown to play a significant role in the outstanding σ_{TPA} values obtained for molecules such as extended porphyrin⁵⁶ or squaraine⁵⁷ derivatives mainly used in two-photon photodynamic therapy.⁵⁸ To the best of our knowledge, only one example has been explicitly reported to date, that concerns two-photon induced microfabrication using cationic polymerization.⁵⁹

Practically, working with a 532 nm pulsed laser, a blue absorbing chromophore structurally optimized following the general principles and guidelines of chromophores design for nonlinear optics (large π -conjugated structure, presence of electron donating and/or withdrawing groups)

can be used as a near-resonant two-photon photosensitizer.

In this paper, we describe the synthesis and detailed characterizations of two such chromophores, using a common set of monomeric building blocks. These chromophores, named **V-Shape** and **Oct**, consist respectively in two and three branched oligo(phenyleneethynylene) derivatives, end terminated with aniline moieties used as strong electron donors. We investigate in detail their linear and non-linear spectroscopic features, and study their mechanisms of decomposition upon photoirradiation. By comparison with commercially available benchmark Norrish I (Irgacure **OXE2**) and II (**BDEBP** and **ITX**) type of PIs (as shown in Figure 1), which have been previously used in two-photon microfabrication,⁶⁰⁻⁶⁵ we identify the nature of the photogenerated radicals and propose a mechanism accounting for their formation.

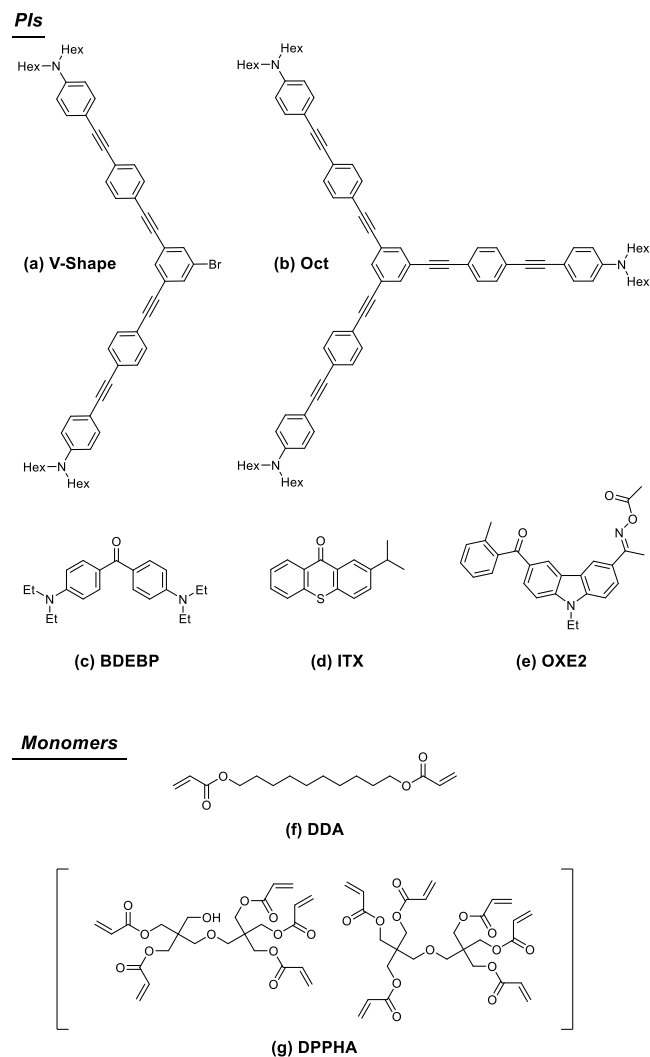


Figure 1. Chemical structures of the five PIs investigated in this study and the two monomers that were used: (a) **V-Shape**; (b) **Oct**; (c) 4,4'-Bis(diethylamino)benzophenone also called Michler's ethyl ketone **BDEBP**; (d) **ITX**; (e) **OXE2** (f) 1,10-decanediol diacrylate **DDA**; (g) dipentaerythritol penta/hexa-acrylate **DPPHA**.

Through a combined spectroscopic and electrochemical study, we study in details the mechanisms of radical generation and polymerization initiation. Finally, we show that the two new PIs reported in the study, when incorporated in a mixture of multifunctional acrylic monomers, provide significant benefits in terms of polymerization sensitivity with a polymerization threshold lowered up to eight times in comparison with archetypical Norrish I (**OXE2**, acyloxime ester) or Norrish II (Michler's ketone derivative, 4,4'-bis(diethylamino)benzophenone **BDEBP** and isopropyl thioxanthone **ITX**) PIs similar to those used in recent works dealing with two-photon microfabrication, while maintaining high-resolution features.

EXPERIMENTAL SECTION

Materials and general methods. All reactions were performed under argon. Solvents were used without further purification. All reagents, including reactant **2** were purchased from Sigma Aldrich, TCI or Alfa Aesar and were used without further purification. The reaction progresses were monitored by thin layer chromatography (TLC) with silica gel 60 F254 using UV lamp detection. Column chromatography was performed using Acros Organics (0.035-0.70 mm) silicagel for purification. Dipentaerythritol penta-/hexa-acrylate (DPPHA) was purchased from Sigma Aldrich and 1,10-decanediol diacrylate (DDA) from TCI. 4,4'-bis(diethylamino)benzophenone also called Michler's ethyl ketone **BDEBP** was purchased from Merck and **OXE2** from Angene Chemical. ^1H and ^{13}C NMR spectra in CDCl_3 were recorded at room temperature on a BRUKER Avance spectrometer operating at 400 MHz for ^1H and 75 MHz for ^{13}C respectively. Chemical shifts are reported in parts per million (δ , ppm) relatively to tetramethylsilane, using residual solvent peaks as internal standards (CHCl_3 ^1H : 7.26 ppm, ^{13}C : 77.36 ppm). Spectra are provided in supporting information (see Figures S1 and S2). High resolution mass spectrometry measurements were performed at Centre Régional de Mesures Physiques de l'Ouest (Université de Rennes, Rennes, France).

Synthesis. Synthesis of compounds **1**, **3** and **4** have been already reported in the literature (

), ⁶⁶⁻⁶⁷

V-Shape: **1** (465 mg, 1.21 mmol) and **2** (114 mg, 0.36 mmol) were dissolved in a mixture of THF (20 mL) and Et_3N (15 mL). The solution was degassed by argon bubbling for 1 hour. Then $\text{Pd}(\text{PPh}_3)_2\text{Cl}_2$ (138 mg, 5.4%) and CuI (69 mg, 10%) were added. The reaction mixture was stirred at 90°C under argon for 48 hours. Solvents were removed under reduced pressure and the crude product was dissolved in dichloromethane. The solution was washed with NH_4Cl , water and pre-dried with saturated NaCl solution. The solution was dried with Na_2SO_4 , filtered and solvents were removed under vacuum pressure. The product was then purified on silica gel with a mixture $\text{PE}/\text{CH}_2\text{Cl}_2$ as eluent (from 9/1 to 8/2, v/v. solid deposition

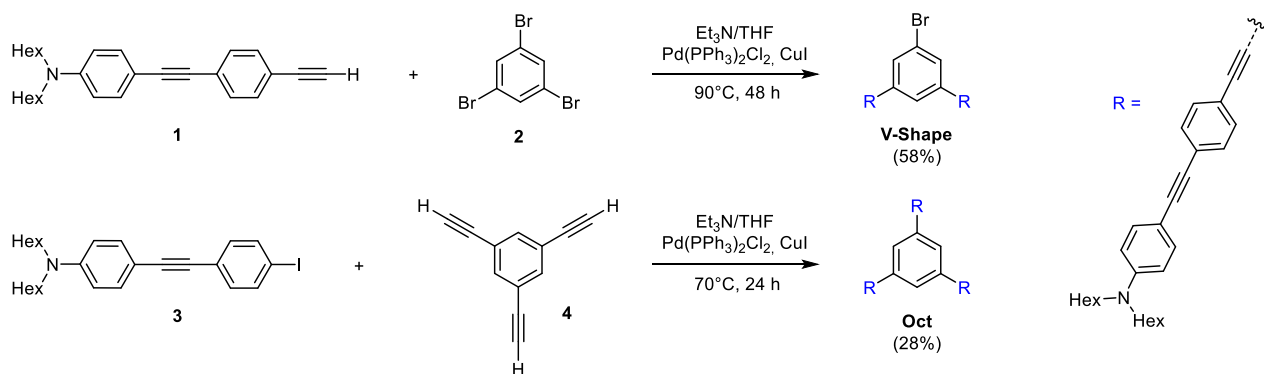
of the product) to give a brown oil (195 mg, 58%). ^1H NMR (400 MHz, CDCl_3): δ 7.65 (d, J = 1.4 Hz, 2H), 7.64 (t, J = 1.3 Hz, 1H), 7.49 (s, 8H), 7.39 (d, J = 8.9 Hz, 4H), 6.60 (d, J = 9.0 Hz, 4H), 3.30 (t, J = 8.1 Hz, 6H), 1.61 (t, J = 7.0 Hz, 8H), 1.36 – 1.33 (m, 24H), 0.93 (t, J = 6.7 Hz, 12H). ^{13}C NMR (75 MHz, CDCl_3): δ 148.2, 133.9, 133.0, 132.3, 131.6, 131.2, 125.3, 124.9, 122.0, 121.1, 111.2, 108.2, 93.5, 91.3, 88.5, 87.0, 51.0, 31.7, 27.2, 26.8, 22.7, 14.1. HRMS (ESI) m/z calcd for $[\text{C}_{62}\text{H}_{71}\text{BrN}_2 + \text{H}]^+$ at 923.48734, found 923.4871.

Oct: 3 (700 mg, 1.44 mmol) and **4** (65 mg, 0.43 mmol) were dissolved in a mixture of THF (15 mL) and Et_3N (10 mL). The solution was degassed by argon bubbling for 1 hour. Then $\text{Pd}(\text{PPh}_3)_2\text{Cl}_2$ (150 mg, 5%) and CuI (80 mg, 9.6%) were added. The reaction mixture was stirred at 70°C under argon for 24 hours. Solvents were removed under reduced pressure and the crude product was dissolved in dichloromethane. The solution was washed with NH_4Cl , water and pre-dried with saturated NaCl solution. The solution was dried with Na_2SO_4 , filtered and solvents were removed under vacuum pressure. The product was then purified on silica gel with a mixture $\text{PE}/\text{CH}_2\text{Cl}_2$ as eluent (from 9/1 to 8/2, v/v. solid deposition) to give a yellow oil (150 mg, 28%). ^1H NMR (400 MHz, CDCl_3): δ 7.64 (s, 3H), 7.48 (s, 12H), 7.37 (d, J = 8.8 Hz, 6H), 6.58 (d, J = 9.0 Hz, 6H), 3.28 (t, J = 7.4 Hz, 12H), 1.59 (t, J = 7.7 Hz, 12H), 1.41 – 1.27 (m, 36H), 0.91 (t, J = 6.6 Hz, 18H). ^{13}C NMR (75 MHz, CDCl_3): δ 148.1, 134.0, 133.0, 131.6, 131.2, 124.7, 124.1, 121.4, 111.2, 108.3, 93.4, 90.6, 89.2, 87.0, 51.0, 31.7, 27.2, 26.8, 22.7, 14.1. HRMS (ESI) m/z calcd for $[\text{C}_{90}\text{H}_{105}\text{N}_3 + \text{H}]^+$ at 1228.83813, found 1228.8375.

Absorption and luminescence. Absorption spectra were recorded on a JASCO V-650 spectrometer in dilute dichloromethane solution (about 10^{-6} mol/L). Emission spectra were measured using a Horiba-Jobin-Yvon Fluorolog-3 spectrofluorimeter equipped with a three-slit double grating excitation and emission monochromator with a dispersion of 2.1 nm/mm (1200 groove/mm). A R928 detector was used. Corrections

were applied for both the excitation light intensity variation (lamp and grating) and the emission spectral response (detector and grating). Absolute fluorescence quantum yields were measured in diluted dichloromethane solutions using a GMP G8 integrating sphere. Sample were introduced into a capillary quartz tube placed into the cavity of the sphere. Differences between the peak intensities of the lamp and the emission profiles were minimized using a density filter (0.5%) to attenuate the lamp signal and thus ensure that the collected signal remained in the linear range of the detector.

Z-Scan TPA measurement. Z-scan measurements were conducted in dichloromethane (spectroscopic grade) solutions for **V-Shape** (0.61 mM), **Oct** (1.52 mM) and **BDEBP** (9.8 mM). The open aperture z-scan method ⁶⁸ was employed for all samples held in 2-mm quartz cuvette.



Scheme 1. Synthesis of target compounds **V-Shape** and **Oct**.

Two measurement procedures were used: (1) wavelength (WL)-scan measurement, where the single-power measurement was repeated for different excitation wavelengths and the z-scan traces were analyzed by assuming TPA process; and (2) power-scan measurement, where measurements were repeated at least with four different incident powers for each excitation wavelength to confirm that the observed nonlinear absorption is dominated by TPA. The combination of these measurement procedures allows us to obtain fast and reliable results because the WL-scan results show the overview of the spectra and the power-scan results for some selected wavelengths make sure that the observed results are caused by TPA. The incident powers (excitation intensities) used differed depending on the wavelength range of the laser *i.e.* the configuration of the femtosecond optical parametric amplifier *Spectra-Physics TOPAS Prime* and were 0.40 mW (80–100 GW/cm²) for 600–900 nm range (SHS, SHI) and 0.25 mW (60–170 GW/cm²) for 485–600 nm range (SFS, SFI) for the WL-scan. On the other hand, power-scan was made for these powers and three weaker powers (factors of 0.7, 0.5 and 0.3). The typical pulse width and the Rayleigh range were 90–120 fs and 6–11 mm although they changed depending on the wavelength. MPPBT/DMSO⁶⁸ and bis-MSB /CLF⁶⁹ were used as reference sample for 600–900 nm and 485–600 nm respectively.

EPR-Spin Trapping (ST). Dichloromethane solutions of each PI in presence of trapping agent (*N-tert*-Butyl- α -phenylnitron PBN, and 5,5-Dimethyl-1-pyrroline N-oxide DMPO) were carefully degassed through five freeze-pump-thaw cycles in quartz EPR tubes. The spectra of the irradiated samples (M365L2 Thorlabs LED, 365nm) were recorded *in situ*. EPR assays were all carried out at room temperature using a Bruker E500 spectrometer operating at X-band (9.33–9.87 GHz), standard cavity, with 100 KHz modulation frequency. The instrument settings were as the following: microwave power: 0.2–64 mW; modulation amplitude: 1 G. Hyperfine coupling constants values were obtained with simulation of experimental spectra using Easyspin (Matlab toolbox) and compared with the literature.

Cyclic Voltamperometry. Cyclic voltammetry (CV) curves have been recorded using a SP300 Biologic potentiostat. All studies were conducted under an argon at-

mosphere in a standard one-compartment three-electrode electrochemical cell. An automatic ohmic drop compensation procedure was systematically performed when using CV. Vitreous carbon ($\varnothing = 3$ mm) working electrodes (CH Instruments) were polished with 2 μ m diamond paste (PRESI SA) before each recording. Ag/AgNO₃ (CH Instruments, 10^{−2} mol/L + TBAP 10^{−1} mol/L in CH₃CN) was used as a reference electrode and bis(η^5 -cyclopentadienyl)iron (ferrocene) was used as an internal reference. Dichloromethane (99.9 %, extra-dry, stabilized with amylene) was purchased from Acros and used as received. Tetra-*n*-butylammonium perchlorate (TBAP, Fluka puriss.) was purchased and dried under vacuum at 60°C for 24 h before use.

DFT calculations. Density functional theory (DFT) calculations were performed with the Gaussian 16 Rev B.01 suite of programs.⁷⁰ Structures of **V-Shape** in the neutral, radical cationic and radical anionic states were computed at the M06HF/6-31G(d,p) level of theory, both in gas phase and in dichloromethane to estimate electronic energies as well as redox potentials. Absolute redox potentials were estimated at 298K, after frequencies calculations according to the computational protocol proposed by Truhlar and coworkers.⁷¹

Stern-Volmer experiments. Emission spectra of the tested PIs in dichloromethane were measured using a Horiba-Jobin Yvon Fluorolog-3 spectrofluorimeter from 375 to 700 nm at room temperature with an excitation at $\lambda_{\text{ex}} = 370$ nm. A concentrated solution of DPPHA at isomolar concentration of PI as in the first solution was then added until reaching the final concentration of DPPHA. No change was observed, indicating an absence of electron or energy transfer between the singlet excited state of **V-Shape** or **Oct** and the monomer.

Photolysis studies. Photolysis studies were performed in a home-made setup consisting of a 365 nm Thorlabs LED (M365L2) equipped with a convex lens (plano-convex $f = 25.4$ mm, Thorlabs) aiming to obtain a beam diameter of about 9 mm through the sample cuvette (10x10mm) placed 10 cm downstream of the LED. LED power was measured on a thermal power sensor (S405C, Thorlabs) placed at the same distance. Prior to the study, dichloromethane solutions of PI in presence or absence of monomer were carefully degassed through five freeze-pump-thaw cycles and were stirred during photolysis.

Microfabrication. *Photoresist preparation:* the PIs were mixed with DDA and stirred for 30 min at room temperature with additional dichloromethane when needed. No solvent was necessary for **V-Shape** and **Oct** solubilization. DPPHA was then added. The solution was stirred mechanically for 1 min and then magnetically for 30 min. Good homogeneity was obtained without filtration, ensuring that the desired concentration was achieved in each photoresists tested.

Fabrication and setup: the 3D microfabrication was carried out using a Microlight3D printer μ FAB-3D based on a Zeiss Axiovert 200 inverted microscope equipped with a XYZ piezo nanomanipulator allowing the translation of the sample relative to the laser focal point, and a CMOS camera mounted behind a dichroic mirror for monitoring of the polymerization process. The laser module includes a microchip self-Q-switched frequency-doubled Nd:YAG laser at 532 nm providing 560 ps pulses at a repetition rate of 11.7 kHz with a maximum average power of 11.5 mW at entrance of the objective. Average laser power were measured at the entrance pupil of the objective on a standard photodiode power sensor (S120VC, Thorlabs). The incident beam was focused with a high numerical aperture objective (x100, NA 1.40, oil immersion, Zeiss Plan-APOCHROMAT). The laser power was controlled by an acousto-optic modulator which was computer-piloted via LITHOS software as well as the displacement of the sample and the scanning speed. The sample consists of a drop of photoresist deposited on a borosilicate coverslip (170 $\mu\text{m} \pm 5 \mu\text{m}$ thick). After the manufacturing process, the structures were obtained by washing away the unreacted monomer with two successive 10-minute acetone baths.

Microstructure characterization: samples were metallized with 5 nm platinum via vacuum deposition with Leica EM ACE600 sputter coater to prevent charge accumulation and enhance the contrast during the following Scanning Electron Microscopy (SEM) observations. The line widths were measured using a top view and the line heights using a grazing view (90°) with a Zeiss Supra 55VP SEM. A home-made python program was used to automatically determine the edges of the lines and give an average value of a line width over a length of several micrometers of the middle of each line. More details are provided in

supporting information. The error bars correspond to the 95% confidence interval given by the student's t-distribution. Thus, it provides information on the error resulting from the measurement of the line widths and heights by SEM. The values were considered without subtracting the thickness of the platinum layer (expected at twice 5 nm i.e. 10 nm).

RESULTS AND DISCUSSION

Synthesis. **V-Shape** and **Oct** were synthesized using a general synthetic approach and building blocks depicted in previous articles.⁶⁶⁻⁶⁷ The final key-step of both syntheses consists in a Sonogashira coupling of respectively a tribromobenzene **2** with the extended alkyne terminated aniline **1**, and three iodoalkyne chains **3** with a 1,3,5-triethynylbenzene **4** (see

), which synthesis has already been reported.⁶⁶ Depending on the reaction conditions, it is possible to drive the reaction towards the almost exclusive formation of either **V-Shape** or **Oct**. The preferential formation of **V-Shape** rather than of **Oct** following the first pathway could be explained by the electron enrichment of the halide through the first two couplings with the alkyne-aniline moiety, which is detrimental to the oxidative addition step of Pd(0) into the remaining carbon-halide bond. Both target materials can be recovered in moderate yields after purification of the crude product on silica gel. Detailed synthetic protocols and characterizations are featured in the experimental section.

Spectroscopy. Main spectroscopic data for both studied molecules are gathered in **Erreur ! Source du renvoi introuvable.**, along with those of the studied benchmark PIs, when available. Both molecules are characterized by a broad and structureless absorption band (see Figure 2) that peaks at the limit between near UV and visible (390 nm) and extends into the violet and blue range of the visible spectra. The shape of the spectrum in dichloromethane solvent, along with the characteristic large oscillator strength, is typical of an intramolecular charge transfer (ICT) band, characteristic of two-photon absorbing chromophores. In addition, a similarly broad fluorescence band is observed peaking at 508 nm and 495 nm for **V-Shape** and **Oct** respectively.

Table 1. Summary of the main photophysical and electrochemical parameters for both molecules and references in dichloromethane: maximum absorption wavelengths ($\lambda_{\text{max-abs}}$), molar extinction coefficients (ϵ) at $\lambda_{\text{max-abs}}$, maximum emission wavelengths ($\lambda_{\text{max-em}}$), fluorescence quantum yields ϕ_f , cathodic peak potential (E_{pc}), anodic peak potential (E_{pa}), standard free energy changes for photoinduced electron transfer (ΔG_{ET}^0) and TPA cross-sections at 532 nm ($\sigma_{\text{TPA}}^{532\text{nm}}$).

PI	$\lambda_{\text{max-abs}}$ (nm)	ϵ (10^4 L/mol/cm)	$\lambda_{\text{max-em}}$ (nm)	ϕ_f (%)	E_{pc} (V)	E_{pa} (V)	ΔG_{ET}^0 (kJ/mol)	$\sigma_{\text{TPA}}^{532\text{nm}}$ (GM)
V-Shape	386	8.9	508	66	-2.33	+0.37	-11.4	1500 \pm 200
Oct	386	14.8	495	79	-2.48	+0.36	-2.3	740 \pm 150
BDEBP	362	4.1	-	-	na	+0.49	na	77 \pm 11
ITX	386 ^a	0.7 ^a	420 ^a	9 ^a	na	na	na	na
OXE2	340	2.1	464	≈ 0	na	na	na	na

Peak potential values measured by CV for **V-Shape**, **Oct** and **BDEBP** (1 mmol/L) in the presence of tetra-*n*-butylammonium perchlorate (0.1 mol/L), $E(V)$ vs. $E_{ref}[Fc/Fc^+]$, at a vitreous carbon working electrode $\varnothing = 3$ mm, 298 K, $\nu = 0.1$ V/s. na: not available. ^a previously reported,⁷² in chloroform.

TPA spectra were measured for both compounds by the Z-scan technique, over a range of wavelengths covering the 500-1000 nm region. In both cases, in addition to the “regular” TPA band corresponding to the $S_0 \rightarrow S_1$ transition (excitation to the lowest lying excited state, similar to that reached upon OPA at 390 nm), another strong TPA transition is also seen, as expected, as the laser wavelength gets closer to the OPA resonance wavelength. Interestingly while σ_{TPA} peaks ca. 500 GM for the regular TPA band, consistent with values usually found on related chromophore with similar π -conjugated architectures,^{66, 73-74} a much higher value is found at the near-resonant TPA band. In particular, at the operating wavelength of the frequency doubled Nd-YAG laser used in our micro-fabrication setup (532 nm), σ_{TPA} reaches a value about 1500 ± 100 GM for **V-Shape**, then increases up to a value ca. 2000 GM at 500 nm. The 532 nm value of **Oct** is significantly lower (740 ± 150 GM), because of a more energetic onset of the near-resonant transition, consistent with the slightly blue-shifted onset of the ICT band in the OPA spectrum, but reaches a similar value at 500 nm (2200 GM). These very high σ_{TPA} values are reminiscent of those found for expanded porphyrin and squaraine derivatives, for which near-resonant enhancement of TPA has been shown to play an important role in the nonlinear response.^{56-57, 75}

Note that the quadratic dependence of the absorption process to the average laser intensity was checked at different characteristic wavelengths (denoted as “power scan” in Figure 2 and Figure S3, and including 532 nm, Figure S4) to ascertain the two-photon nature of the monitored process at these wavelengths.⁷⁶

EPR spin trapping (EPR-ST) studies. To further demonstrate the applicability of our newly designed chromophores for two-photon microfabrication, photoinduced radical generation upon continuous irradiation of dichloromethane solution of **V-Shape** was studied by means of EPR-ST spectroscopy. To facilitate identification of the generated radical, EPR signals and spectral simulations were systematically compared to those obtained with literature benchmarks. In addition to our aforementioned Norrish I (**OXE2**) and Norrish II (**BDEBP**) PIs, azobisisobutyronitrile (**AIBN**) was also used to verify the reliability of the approach. **AIBN** is known to efficiently produce a single radical species upon thermal or photodegradation, and should in principle lead to a unique EPR signal. Moreover, in order to facilitate radical detection, radical scavengers *N*-tert-butyl- α -phenylnitron (PBN), and 5,5-dimethyl-1-pyrroline N-oxide (DMPO) were used for each compound, and the results obtained with those two scavengers were systematically compared.

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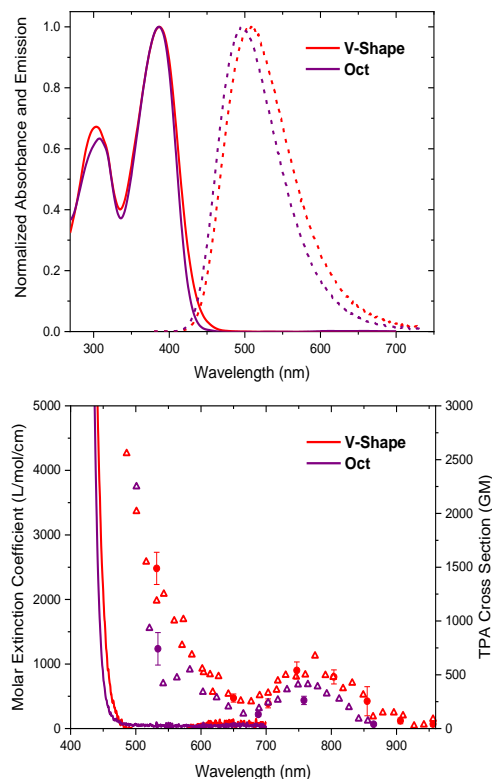


Figure 2. Normalized absorption (solid lines) and emission spectra (dashed lines) of **V-Shape** (red) and **Oct** (purple) in dichloromethane (top figure). The red-tail of OPA spectra (solid lines) along with TPA spectra of **V-Shape** (red) and **Oct** (purple) in dichloromethane obtained by wavelength (WL)-scan measurement (empty triangles) at a constant incident power and power scan measurement (full circle) performed with four irradiation powers at each wavelength, by which it proves that the observed signal originates from TPA for the selected wavelengths (bottom figure).

To facilitate identification of the generated radical, EPR signals and spectral simulations were systematically compared to those obtained with literature benchmarks. In addition to our aforementioned Norrish I (**OXE2**) and Norrish II (**BDEBP**) PIs, azobisisobutyronitrile (**AIBN**) was also used to verify the reliability of the approach. **AIBN** is known to efficiently produce a single radical species upon thermal or photodegradation, and should in principle lead to a unique EPR signal. Moreover, in order to facilitate radical detection, radical scavengers *N*-tert-butyl- α -phenylnitron (PBN), and 5,5-dimethyl-1-pyrroline N-oxide (DMPO) were used for each compound, and the results obtained with those two scavengers were systematically compared.

As expected, a single radical species was obtained in the presence of **AIBN**, whatever scavenger considered. The features of the trapped radical species as monitored in either PBN ($a_N = 14.1$, $a_H = 2$ G) or DMPO ($a_N = 13.0$ G, $a_H = 8.9$ G, $a_H = 1.5$ G) are consistent with a radical species originating from the classical decomposition mechanism of AIBN, after possible oxidation with traces of oxygen contained within the medium as found in previous works with this initiator (see Figure S5).⁷⁷

Irradiation of **OXE2** gives a more complex pattern; in addition to the previously reported spin-adduct corresponding to an acetoxyl COO^\bullet radical (adduct of PBN: $a_N = 13.5$ G and $a_H = 1.6$ G; adduct of DMPO: $a_N = 12.8$ G, $a_H = 10.3$ G and $a_H = 1.1$ G),^{36, 78} three other species were also identified. In the first, hyperfine coupling constants are consistent with the methyl radical CH_3^\bullet (adduct of PBN: $a_N = 15.1$ G and $a_H = 3.4$ G; adduct of DMPO: $a_N = 14.7$ G and $a_H = 20.5$ G), which agrees with a mechanism consisting in a CO_2 elimination from the acetoxyl radical. A last adduct, which we attribute to iminyl radical resulting from the N-O bond photocleavage was similarly observed with both trapping agents (adduct of PBN: $a_N = 13.9$ G and $a_H = 2.3$ G; adduct of DMPO: $a_N = 14.5$ G and $a_H = 15$ G). In addition, an adduct of DMPO highlights the presence of another species consistent with reported values for acetyl radical ($a_N = 13.0$ G, $a_H = 7.0$ G and $a_H = 1.5$ G) even though the presence of this species is not fully understood. Note that this radical may also be present in PBN, but its expected feature may render it undistinguishable from the iminyl radical. In addition to these signals, a triplet signal due to the degradation of DMPO ($a_N = 13.9$ G)⁷⁹ is visible in the corresponding EPR spectrum (see Figure S5).

In contrast, strong similarities are seen for the dominant radical species obtained with **BDEBP** and **V-Shape** (see below and Figure 3). By analogy with previous studies and general agreement on Michler's ketone (or related molecules⁸⁰) photoinitiation mechanism,⁸¹ and taking in consideration the structural analogies between the former and **V-Shape**, we attribute the observed first radical species trapped with PBN to a C-centered radical in alpha position of the aliphatic chain, relative to the aniline group ($a_{N\text{-BDEBP}} = 14$ G, $a_{H\text{-BDEBP}} = 2.2$ G; $a_{N\text{-V-Shape}} = 14.6$ G, $a_{H\text{-V-Shape}} = 2.5$ G). The hyperfine coupling constants indeed fully match those previously described in literature.⁸²⁻⁸³ A second signal common to both PIs ($a_N = 8.1$ G) can be attributed to a degradation of PBN,⁷⁹ finally a third species is observed with **BDEBP** exclusively ($a_{N\text{-BDEBP}} = 14.8$ G, $a_{H\text{-BDEBP}} = 4.6$ G): its signature corresponds to a C-centered radical, located on the carbonyl moieties, and is typically encountered with benzophenone derivatives.⁸⁴⁻⁸⁵ It is therefore absent from **V-Shape** signature, the latter being devoid of a carbonyl function.

By analogy with literature, the first signal observed in DMPO ($a_{N\text{-BDEBP}} = 14.5$ G, $a_{H\text{-BDEBP}} = 21$ G; $a_{N\text{-V-Shape}} = 14.5$ G, $a_{H\text{-V-Shape}} = 21.5$ G) may correspond to adducts of the same species described with a possible superimposition of the two C-centered signals in the case of **BDEBP**. Due to the better ability of DMPO to trap N and O-centered radicals, we attribute the second and major species ($a_{N\text{-BDEBP}} = 13.5$ G, $a_{H\text{-BDEBP}} = 11.7$ G; $a_{N\text{-V-Shape}} = 13.4$ G, $a_{H\text{-V-Shape}} = 11.4$ G) to an N-centered (i.e. on the aniline nitrogen) cation radical. Eventually, a signal corresponding to the degradation of DMPO was observed for both PIs ($a_N = 13.9$ G).⁷⁹ These species are consistent with a mechanism consisting an initial electron transfer step, which then evolves through hydrogen abstraction from another PI molecule or the solvent. It constitutes another indication that **V-Shape** (and **Oct**, by extension) most probably proceed through an initial homo-intermolecular electron transfer, and that the resulting radical possibly evolves by hydrogen abstraction, a point that also receives support from TD-DFT computational modeling (vide infra).

Shape = 11.4 G) to an N-centered (i.e. on the aniline nitrogen) cation radical. Eventually, a signal corresponding to the degradation of DMPO was observed for both PIs ($a_N = 13.9$ G).⁷⁹ These species are consistent with a mechanism consisting an initial electron transfer step, which then evolves through hydrogen abstraction from another PI molecule or the solvent. It constitutes another indication that **V-Shape** (and **Oct**, by extension) most probably proceed through an initial homo-intermolecular electron transfer, and that the resulting radical possibly evolves by hydrogen abstraction, a point that also receives support from TD-DFT computational modeling (vide infra).

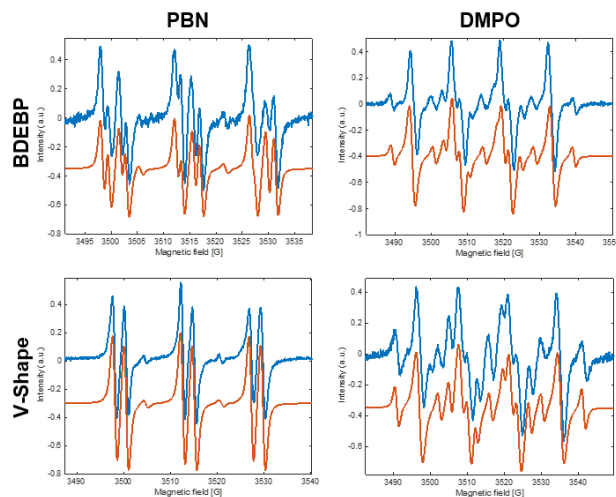


Figure 3. EPR spectra of spin trap adducts generated after irradiation of **BDEBP** and **V-Shape** at 365 nm in presence of PBN or DMPO in dichloromethane. Experimental spectra (blue) and simulated spectra (orange).

Electrochemical studies. The thermodynamic feasibility of such a photoredox process was further demonstrated by electrochemical methods. The oxidation and reduction potentials of **V-Shape** and **Oct** were determined by CV measurements carried out in deoxygenated dichloromethane in the presence of tetra-*n*-butylammonium (0.1 mol/L). As a general statement, the thermodynamic driving force for electron transfer (ET) can be calculated using the following equation, sometimes abusively referred to as the Rehm-Weller relation (see Equation 2):⁸⁶

$$\Delta G_{ET} = F[E^\circ(D^+/D) - E^\circ(A/A^-) - \Delta E_{00}] + w_p \quad (2)$$

Where F is the Faraday constant, $E^\circ(D^+/D)$ and $E^\circ(A/A^-)$ stand for the donor and acceptor oxidation and reduction potentials, respectively (or the lowest oxidation and reduction potential of the PI, in the case of an homo-intermolecular process like here), ΔE_{00} (eV) is the so-called zero-zero transition energy, i.e. the energy difference between the vibrationally relaxed ground and excited states of the molecule, which corresponds in the case of a fluorophore to the crossing point of its normalized absorption and emission spectra, and w_p is the Coulomb stabilization energy associated with the intermediate radical ion pair interaction energy with the solvent. The latter is usually neglected in a first approximation.

As can be seen in Figure 4, the CV curves of **V-Shape** and **Oct** display similar signatures, with one irreversible oxidation wave observed at about 0.35 V and one irreversible reduction wave between -2.3 and -2.5 V (see Table 1). The irreversibility of these CV waves reveal the limited stability of both the oxidized and reduced species generated at the electrode interface. The cation radical moieties produced at 0.35 V on the CV curves of **V-Shape** and **Oct** was found to be unstable at all investigated scan rates (100-20 V/s) and the existence of chemical reactions coupled to the electron transfer was revealed on the CV curves by the observation of additional waves on the return scan ($E < -0.5$ V). Both the oxidation potential and observed behavior agree well with the formation of an $(\text{Hex})_2\text{ArN}^{+\bullet}$ cation radical.⁸⁷ Density functional theory (DFT) calculations carried out on the oxidized and reduced forms of **V-Shape** suggest the formation of a stable radical anion, with an extensive delocalization of the electron density contributing to its stability whereas the radical cation is localized at the aniline moieties (see energetic diagram and spin densities given in Figure S6). The latter is prone to deprotonate spontaneously with a marked exergonicity at the aliphatic C adjacent to the aniline center, in good agreement with the conclusions drawn on the basis of EPR data. Calculated oxidation potentials agree well the ones measured experimentally (see ESI).

On the cathodic side, the reductions of **V-Shape** and **Oct** are observed at significantly different potential values. This shift of ~150 mV observed between those two irreversible waves is however fully consistent with the presence of an electron withdrawing bromine atom on **V-Shape**; which supports the conclusion that the electron transfer is centered in both cases on the conjugated pol-aryl backbone.

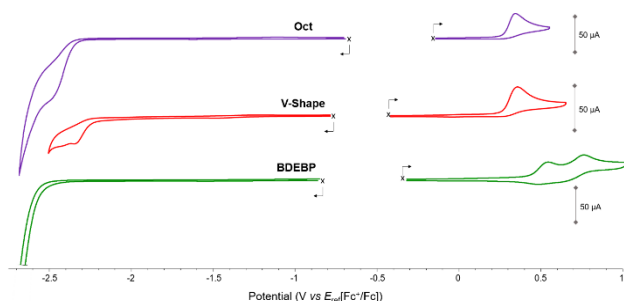


Figure 4. Cyclic voltammetry of **V-Shape**, **Oct** and **BDEBP** (1 mmol/L) in dichloromethane in the presence of tetra-*n*-butylammonium perchlorate (0.1 mol/L), $E(\text{V})$ vs. $E_{\text{ref}} [\text{Fc}^+/\text{Fc}]$, at a vitreous carbon working electrode $\varnothing = 3$ mm, 298 K, $\nu = 0.1$ V/s.

The distribution of spin densities obtained at the DFT/M06HF/6-31G(d,p) shown in Figure S6 indicates a stronger delocalization of the radical anion, hence more stable. Here again, the irreversibility of both CV waves reveals the unstable character of the electrogenerated an-

ion radicals which could potentially be involved in hydrogen abstraction, radical-radical coupling reactions or in the hydrogenolysis of the carbon-halogen bond.⁸⁸

From the spectroscopic data, ΔE_{00} is found at 440 nm and 433 nm for **V-Shape** and **Oct** respectively (2.82 and 2.87 eV). From Equation 2, a standard Gibbs energy for the ET between two **V-Shape** or **Oct** molecules can be calculated, corresponding to -11.4 and -2.3 kJ/mol. Similar experiments were also performed on **BDEBP** (see Figure 4), unfortunately reduction potentials lie outside of the accessible electrochemical window, precluding calculation of the free energy for the homo-intermolecular electron transfer in this case.

CV measurements were also conducted on the monomer. No accessible oxidation or reduction potential could be recorded within the electrochemical window (see Figure S7), *a priori* discarding the possibility of a photoinduced ET with any of the PIs during the photoinitiation process, in contrast with other literature reports.⁸⁹ This was further confirmed by a Stern-Volmer experiment⁹⁰ where evolution of the luminescence intensity of **V-Shape** and **Oct** was monitored upon incremental addition of increasing monomer (DPPHA) concentration (see Figure S8). As no evolution was seen even at high monomer concentration, it can be concluded that no electron or energy transfer takes place between the singlet excited state of **V-Shape** or **Oct** and the monomer.

In summary, these data clearly outline the possibility of an exergonic photoinduced disproportionation for **V-Shape** and **Oct**. These data, in line with EPR results, strongly suggest that this electron transfer constitutes the initial step leading to radical formation and polymerization initiation in the microfabrication process.

Photolysis experiments. Spectroscopic study of the photolysis of PIs was then undertaken in order to gain more insight into the kinetics of the radical generation process, and to test how the latter is influenced by the presence of monomers. It has been shown in previous literature reports that, in these strictly anaerobic conditions, photodegradation of PIs proceeds through formation of photoinduced radical species which evolve, in the absence of scavenging species, to the build-up of photolysis products. Thus, photobleaching rate can be correlated to radical photogeneration efficiency, as recently exemplified by Lalevée et al. or Liska et al.⁹¹⁻⁹⁵ Kinetics of chromophores photobleaching upon continuous irradiation in the ICT band were investigated upon irradiation with a LED at 365 nm, by measuring the in-time decay of luminescence signal intensity, using thoroughly deaerated (five freeze-pump-thaw cycles with a secondary vacuum pump) solution of **V-Shape** and **Oct** in dichloromethane. Evolution of the UV-vis spectra were also monitored in parallel (see Figure 5 and Figure S9).

In the present case, large changes of the isosbestic point at around 360 nm in the absorption spectrum throughout the experiment could be evidenced for both **V-Shape** and **Oct**, with a similar evolution profile in both cases. This indicates a non-straightforward degradation process involving multiple competitive pathways. Two steps at least can be distinguished: in the first 10 minutes, a decrease of ICT band, which can be attributed to the decomposition of **V-**

Shape (or **Oct**), is associated to the concomitant increase of the absorbance at 359 nm and 325 nm. Then, while decrease of the ICT band slowly proceeds forward, the newly formed bands at 359 nm and 325 nm in turn start to decrease, leading to a drift of the isosbestic point. This double evolution suggests the formation (first step) and consumption (second step) of degradation products of the PIs.

In spite of the relatively intricate profile of photo-induced degradation process, attempts were made to fit the first ten minutes of the recorded evolutions to a simple kinetic model. A relatively good correlation was obtained in the case of **V-Shape** and **Oct** with an apparent first order reaction (see Figure 6 and Figure S10),⁹⁶ which seemingly disagrees with the hypothesis of bimolecular electron transfer. However, one has to take into account that the range of studied concentrations (ca. 10^{-6} M), as imposed

by the spectrofluorimetric experiment, may affect the radical generation mechanism: in particular, such low concentrations are reportedly known to strongly disfavor bimolecular mechanisms in favor of direct hydrogen abstraction with the solvent, which might account for the observed discrepancies.⁹⁷

Photolytic rates were found to follow the trend: **BDEBP** >> **Oct** > **V-Shape**. This indicates that **BDEBP** generates radicals more efficiently than **Oct** which itself is slightly more efficient than **V-Shape**. This result is consistent with the fact that the molecular design of **V-Shape** and **Oct** was primarily aimed at improving σ_{TPA} rather than the radical generation efficiency. The difference between **V-Shape** and **Oct** might be attributed to the extra arm of **Oct** since the radicals are expected to be formed in a position of the aniline.

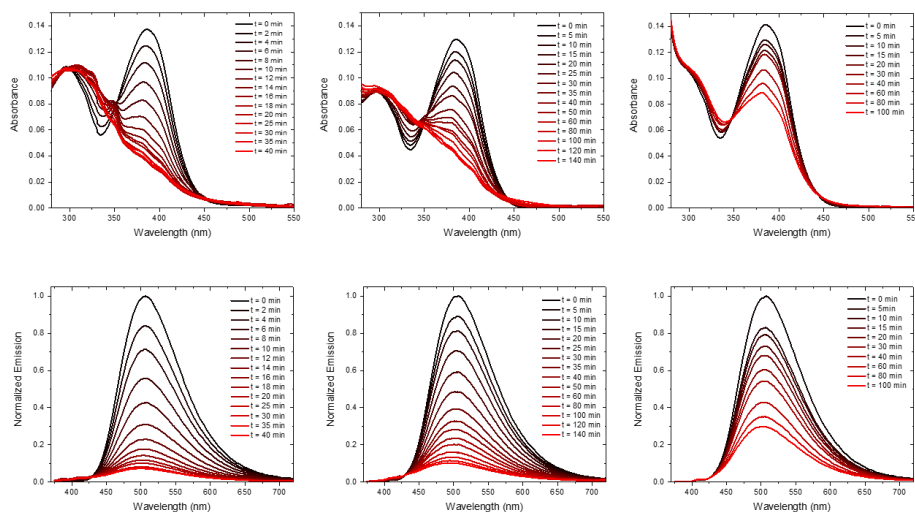


Figure 5. Photolysis studies (UV-Vis and fluorescence) of **V-Shape** in degassed dichloromethane under 365 nm irradiation, 40 mW in absence or presence of Ethyl Acrylate (EA). [**V-Shape**] = 1.4×10^{-6} mol/L; [EA] = 0 mol/L (left); 1.4×10^{-3} mol/L (center) and 7×10^{-3} mol/L (right).

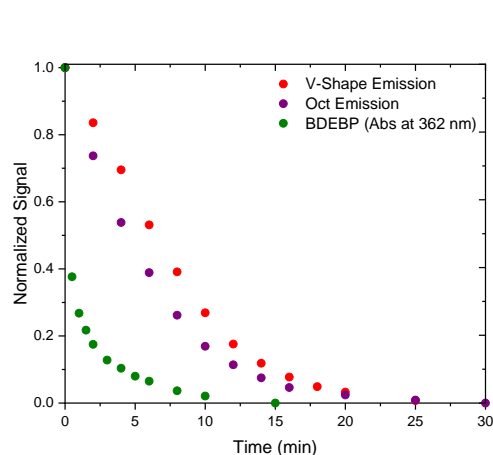


Figure 6. Photolysis of **V-Shape** (red), **Oct** (purple) and **BDEBP** (green) in degassed dichloromethane under 365 nm irradiation, 40 mW at isoabsorbance concentration at 365

nm. [**V-Shape**] = 1.4×10^{-6} mol/L; [**Oct**] = 8.6×10^{-7} mol/L and [**BDEBP**] = 2.6×10^{-6} mol/L.

Moreover, it was unambiguously shown that addition of monomer (Ethyl Acrylate EA and DPPHA) markedly slows down the photobleaching of **V-Shape** and **Oct** (see Figure 7 and Figure S11). The extent of this slow-down appears to be monomer concentration dependent. Taken together with the electrochemical and Stern-Volmer data (see above), we hypothesize from this last result that the photoinitiation mechanism takes place in two consecutive steps i/ an initial photoinduced disproportionation of PI, generating the corresponding radical anion and radical cation pairs; in the absence of monomer or other scavenging species, these species evolve towards terminal degradation products, ii/ an electron transfer towards (or alternatively, radical addition unto) monomer molecules, which restores at least a part of the chromophore (one or two arms) to its initial state and prevents its evolution towards degradation products so that the initial signal of fluorescence and absorbance is at least partially restored.

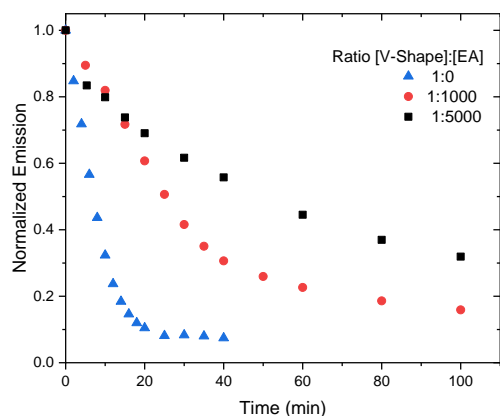


Figure 7. Photolysis kinetics followed by fluorescence measurement of **V-Shape** (top) and **Oct** (bottom) in degassed dichloromethane under 365 nm irradiation, 40 mW in absence or presence of EA. $[\text{V-Shape}] = 1.4 \times 10^{-6} \text{ mol/L}$; $[\text{Oct}] = 8.6 \times 10^{-7} \text{ mol/L}$; $[\text{EA}] = 0 \text{ mol/L}$ (blue); $1.4 \times 10^{-3} \text{ mol/L}$ (red); $7 \times 10^{-3} \text{ mol/L}$ (black).

Two-photon induced 3D microfabrication. With this information in hands, we finally studied the potential of **V-Shape** and **Oct** for the two-photon polymerization (TPP) of acrylic monomers. Our main concern was to compare the polymerization threshold (P_{th}) obtained with **V-Shape** and **Oct** with benchmark PIs, and see whether lowering of this value could be obtained without affecting the accessible resolution.

As presented earlier, design of the newly synthesized PIs involves hexyl substitution on the terminal aniline moieties. The purpose of this long alkyl group was to improve chromophore solubility in the photoresist formulation, such long π -conjugated structures featuring large σ_{TPA} being particularly prone to aggregation because of π -stacking. To take advantage of this feature and maximize PI

solubility, a reactive “diluent” was introduced within the resist formulation, in the form of 1,10-decanediol diacrylate (DDA), a difunctional acrylic monomer featuring a long fatty alkyl chain. The rest of the resist (80wt%) consisted in dipentaerythritol penta-/hexa-acrylate (DPPHA). The latter was chosen as its high functionality provides an excellent crosslinking density, which improves photoresist sensitivity as well as mechanical strength and reduces shrinkage of the generated pattern.⁹⁸

This formulation afforded a maximal 1wt% (10.9 mmol/g) solubility of **V-Shape** upon direct mixing with the monomers. In contrast, the solubility of **Oct** remained limited to 0.66wt% (5.4 mmol/g) and was not improved with addition of co-solvent and sonication which we attribute to a larger π -conjugated backbone.

In order to evaluate P_{th} and minimal accessible size of photogenerated polymers, two types of objects were fabricated. We considered that polymerization threshold was reached when the photogenerated structures could uphold the monomer washing step without undergoing significant distortion (see Figure 8d). As a first model structure, 20 μm lines were printed directly at the surface of the coverslip paying close attention to the level of the laser focus position in order to be exactly at or slightly above the substrate/photoresist interface and thus measuring the correct linewidth while maintaining a good adhesion to the substrate. Figure 8d is a SEM image of periodic lines fabricated with decreasing power at 40 $\mu\text{m/s}$ writing speed. Although suspended lines are often preferred in literature for related studies,⁹⁹⁻¹⁰⁰ this choice of structures present the advantage of being extremely rapid to implement, on the one hand, and to reduce the impact of the shrinkage on the measurement of the linewidth on the other (structures being stabilized by anchoring to the coverslip).¹⁰¹ Moreover, it limits the potential deformation due to spherical aberrations.¹⁵

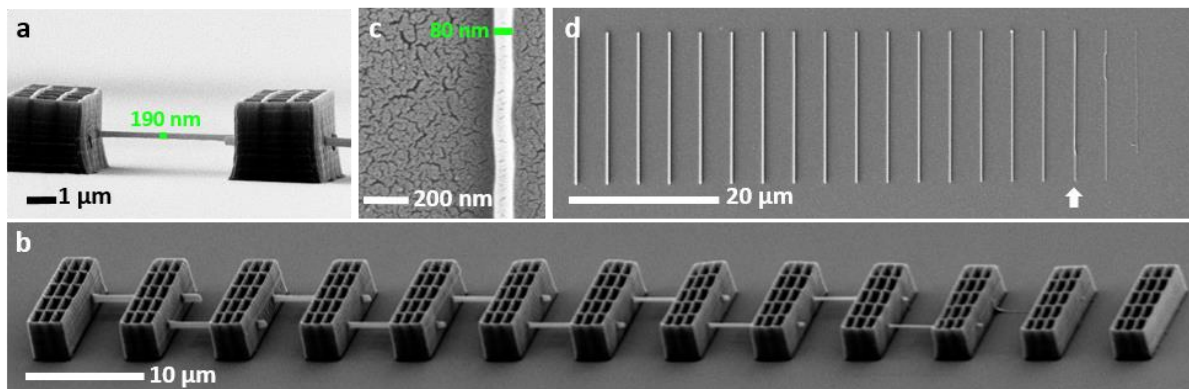


Figure 8. SEM pictures of representative structures generated by TPP for the measurements of the polymerization thresholds, the linewidths and the line heights. Scan speed: 40 $\mu\text{m/s}$. (a) Grazing view of a suspended line, photoresist: DPPHA:DDA:**V-Shape** (79.2:19.8:1), P_{av} 103 μW (b) 45° view of suspended lines, photoresist: DPPHA:DDA:**V-Shape** (79.2:19.8:1), P_{av} from 257 to 82 μW (c) Top view of a line written at the surface of the coverslip, photoresist: DPPHA:DDA:**Oct** (79.5:19.8:0.7), P_{av} 96 μW (d) Top view of lines written at the surface of the coverslip, the white arrow points to the line at the threshold, photoresist: DPPHA:DDA:**Oct** (79.5:19.8:0.7), P_{av} from 303 to 85 μW .

However, it does not provide reliable measurement of the line heights. Thus for comparison, suspended lines were also printed to check for compliance with the results obtained with attached lines, and enable estimation of the aforementioned parameter. 13 μm lines were hanged between 5 μm -separated blocks at 1.5 μm from the surface (see Figure 8a and b) to ensure good mechanical stability.

The general protocol used for systematic measurement of line width and height are reported in the experimental section and detailed in ESI (see Figure S12). Basically, a Python script was designed to provide statistical treatment on a large number of measurements. Generally speaking, no significant difference was found between suspended and surface grafted lines for what concerns linewidth, while the line height and aspect ratio could be measured on suspended lines exclusively, with a value of *ca.* 2.7, typical of TPP using high NA objective.¹⁰² (see Figure S13). However, it could be noted that the width of the suspended lines is slightly inferior to the width of the equivalent lines attached to the coverslip at low laser power (near threshold). This could be due to moderate shrinkage of the structure, more visible at low monomer conversion. In the following, we thus chose to focus on surface grafted lines for the determination of P_{th} .

Table 2. Comparison of the obtained P_{th} between the studied photoresists. Composition: DPPHA:DDA (80:20) with 5.4 μmol PI/g; scanning speed: 40 $\mu\text{m/s}$.

PI	TPP P_{th} (μW)
V-Shape	120
Oct	90
BDEBP	550
ITX	690
OXE2	480

Following this procedure we compared P_{th} between **V-Shape**, **Oct** and our three benchmark compounds, in the monomer mixture described above (see Table 2).

It clearly appears that the polymerization thresholds are significantly improved when comparing **Oct** and **V-Shape** to the benchmarks. Threshold is lowered by approximately a factor 5-6 as compared to **BDEBP**, 6-8 as compared to **ITX** and 4-5 as compared to **OXE2** for **V-Shape** and **Oct** respectively. This improvement could be explained by the much increased σ_{TPA} of the newly designed PIs as compared to commercially available benchmarks. It clearly indicates that **V-Shape** and **Oct** constitute a very promising basis for the future development of improved PIs for two-photon induced polymerization.

In spite of a σ_{TPA} more than one order of magnitude higher for **V-shape** and **Oct** than for **BDEBP**, P_{th} is only improved by a factor of *ca.* 5. The lower absorption of **BDEBP** seems partly compensated by its better radical generation ability (*vide supra*). A similar reason might also account for the lower threshold of **Oct** as compared with **V-Shape**, while σ_{TPA} measurements would suggest an opposite trend.

In a last set of experiments, dependence of the accessible structure size to irradiance was evaluated for each compound.

As expected, the linewidth increases upon increasing the laser power used during the microfabrication process. Although the observed evolution looks at first sight to be very dependent on the nature of the PI, the impression vanishes when the evolution is plotted not *versus* the absolute laser beam intensity, but *versus* the ratio of applied power in regard with the P_{th} value (see inset in Figure 9 and Figure S14). Using this representation, it becomes apparent that the photoresists display a power-dependence pattern that is similar for all PIs: in all cases, initial evolution of the structure dimension can be modeled using the “beam shape dependence function” presented below (see Equation 3) for power that does not exceed twice P_{th} .^{30, 103}

$$v_i = w_{xy} \sqrt{2 \ln \frac{P_i}{P_{th}}} \quad (3)$$

Where v_i is the voxel width obtained with the laser power P_i , w_{xy} is the beam waist in the x-y plane, and P_{th} is the TPP threshold. As shown in Figures S15 and 16, the obtained linewidths are satisfactorily reproduced with Equation 3.

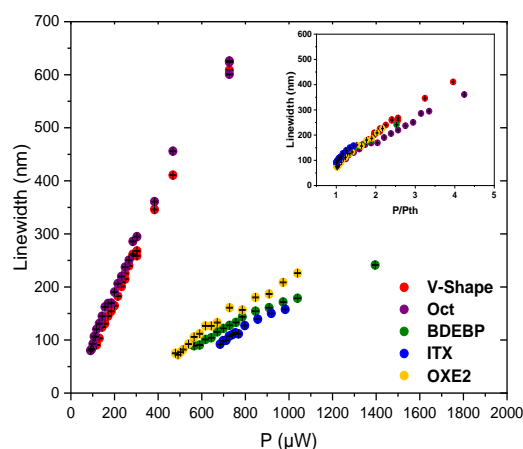


Figure 9. Linewidth versus average laser power and ratio average power/threshold power (inset) for the five studied photoresists.

Finally, in order to illustrate the potential of the newly synthesized photoresists for low-threshold two-photon printing of sub-100 nm resolution structures, we envisioned the fabrication of a 250 nm periodic grating and cubic woodpiles as those presented in Figure 10. A lateral resolution as small as 80 nm and an axial resolution as small as 190 nm were thus demonstrated using a low-cost sub-nanosecond pulsed 532 nm laser (see Figure 8a, c and Figure 10), proving that excellent resolution is maintained with our system.

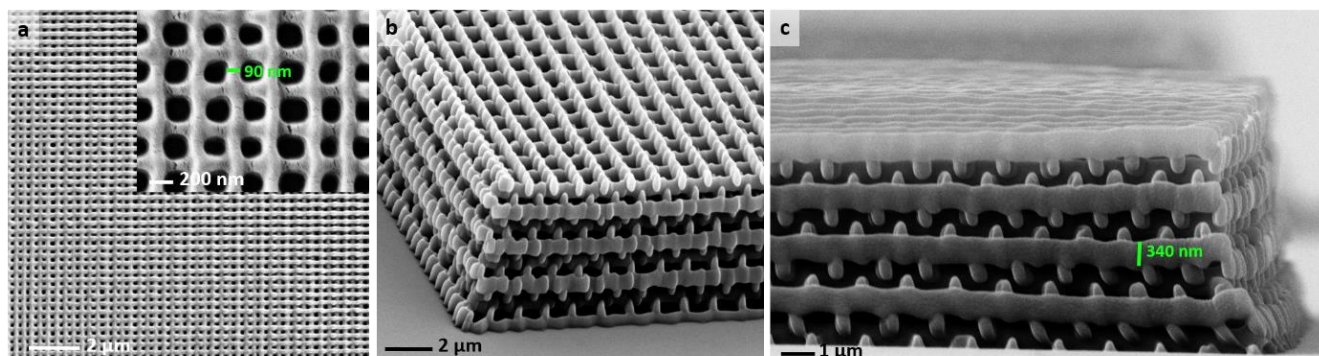


Figure 10. SEM pictures of representative structures generated by TPP. Writing speed 40 $\mu\text{m/s}$, photoresist: DPPHA:DDA:V-Shape (79.2:19.8:1) (a) Top view of a 250 nm periodic grating with a close-up in the upper right corner, P_{av} 103 μW (b) 45° view of a 700 nm-cubic woodpile, P_{av} 125 μW (c) Grazing view of a 700 nm-cubic woodpile, P_{av} 125 μW

CONCLUSIONS

In conclusion, we show that highly efficient radical two-photon initiators can be obtained taking advantage of near-resonant enhancement of the two-photon cross-section efficiency. Taking a simple π -conjugated structure, that displays intense one-photon absorption in the blue part of the UV-vis spectrum, yet only moderate two-photon efficiency in the regular TPA range (with $\lambda_{\text{TPA}} = 2 \times \lambda_{\text{OPA}}$, ca. 800 nm), we show that it is possible to obtain σ_{TPA} values that reach, for one of the studied compounds, 1500 GM at the 532 nm operating wavelength of the laser (close to λ_{OPA}) used in our microfabrication setup.

Owing to their extended π -conjugated structures, the as designed PIs have accessible electrochemical potential in oxidation as well as in reduction, rendering photoinduced disproportionation thermodynamically allowed. As a result, photoinduced radical generation takes place upon PI irradiation, which can be used to efficiently initiate polymerization reactions. Both PIs being functionalized by long alkyl chain that favors their solubility in organic media, they can be readily solubilized within acrylic mixtures for direct use in two-photon microfabrication without additional preparation step. We illustrate the benefit of this approach by comparing the polymerization threshold obtained with both newly synthesized PIs to Norrish I and Norrish II type ones classically used for two-photon microfabrication with sub-nanosecond pulsed 532 nm lasers. Using similar photoresist formulation, the polymerization threshold was lowered up to eight times with the reported new PIs as compared to benchmarks, similar to some of the best reported PIs to date, in spite of a comparatively lower radical generation efficiency. Finally, we show that the improvement in polymerization threshold is not obtained at the expense of resolution, as illustrated with the fabrication of thin bridges and periodic structures with periodic distance of 250 nm which makes both new PIs (V-

Shape and Oct) excellent candidates for massive parallel printing of large surfaces.

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Notes

The authors declare no competing financial interest.

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Supporting Information

Polymerization Photoinitiators with Near-Resonance Enhanced Two-Photon Absorption Cross-Section towards High-Resolution Photoresists with Improved Sensitivity

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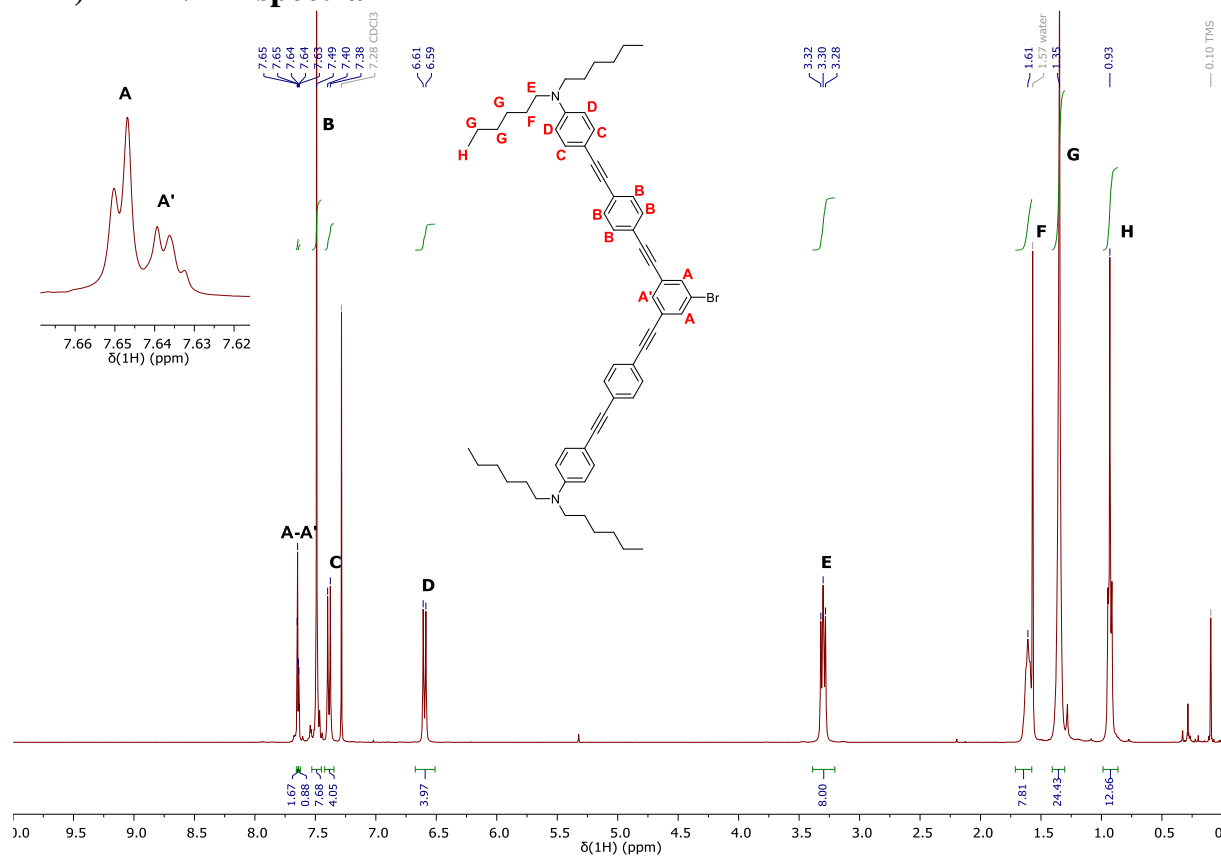
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I) NMR spectra



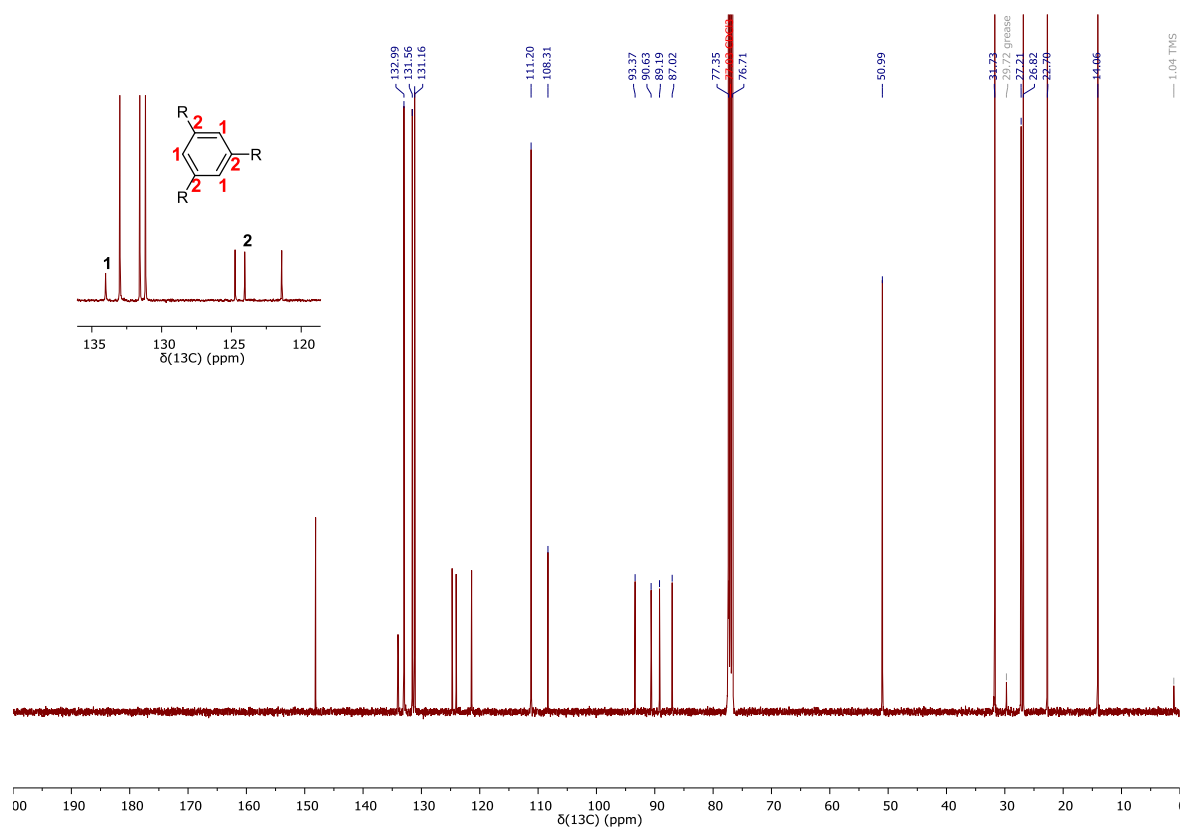


Figure S12. ¹H and ¹³C NMR spectra of **Oct** in CDCl₃.

II) Two-photon cross-section measurements

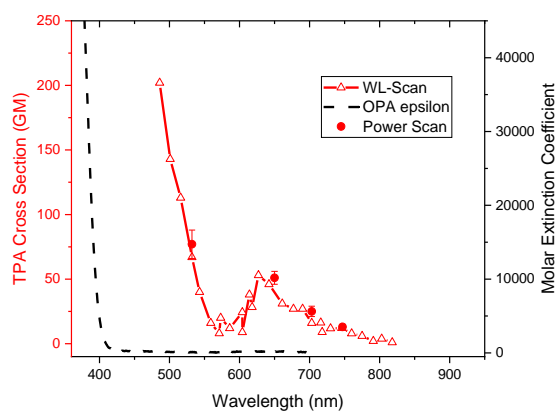
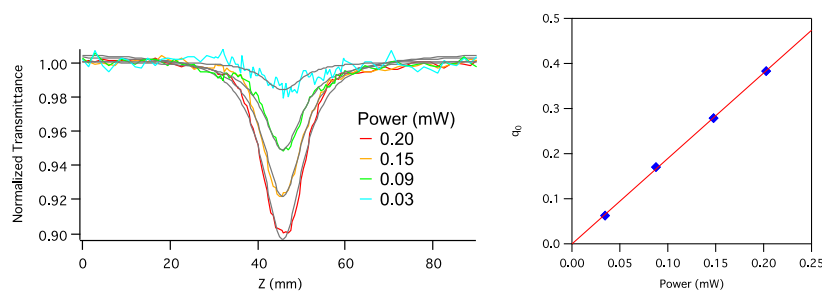
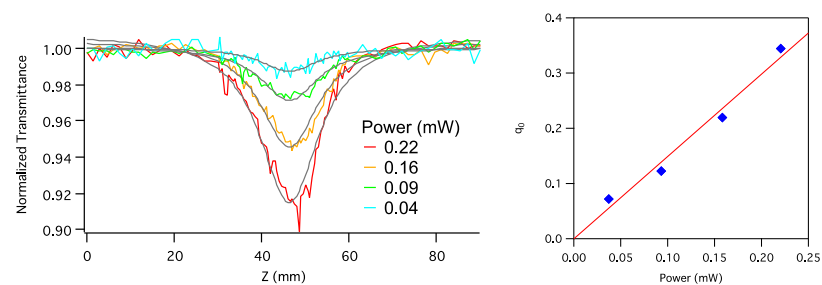


Figure S13. TPA spectra of **BDEBP** (red) in dichloromethane obtained by wavelength (WL)-scan measurement and power scan measurement for some selected wavelengths with a close-up on the chromophore's absorption tail (black dotted line).

V-Shape



Oct



BDEBP

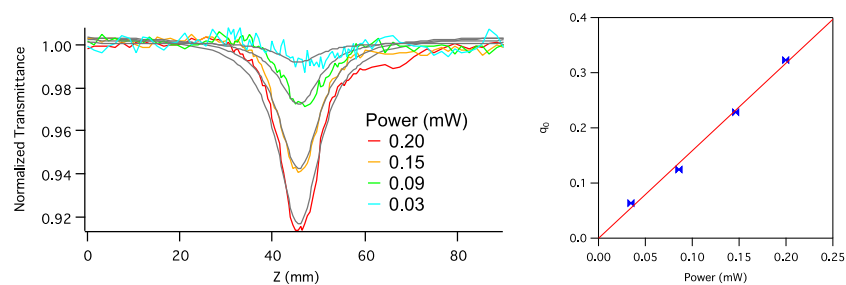


Figure S14. Open-aperture z-scan traces by power-scan at 532 nm and corresponding plot of the two-photon absorbance q_0 vs. the incident power.

III) EPR-ST

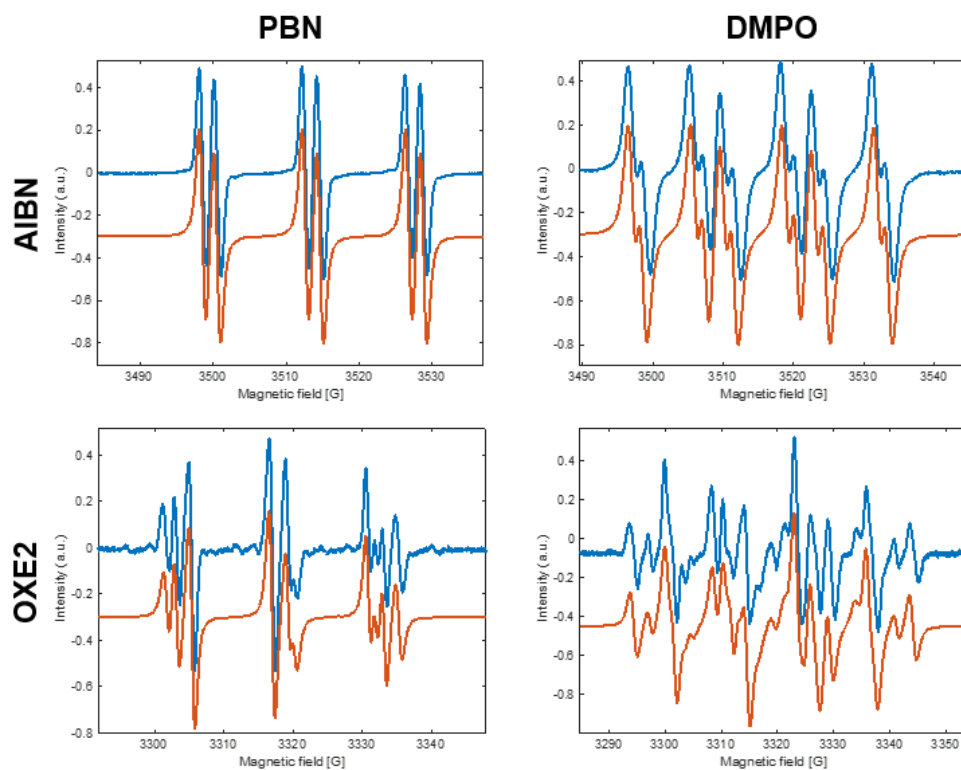


Figure S15. EPR spectra of spin trap adducts generated after irradiation of the *AIBN* and *OXE2* at 365 nm in presence of *PBN* or *DMPO* in dichloromethane. Experimental spectra (blue) and simulated spectra (orange).

IV) Computation methodology

Density functional theory (DFT) calculations were performed at the M06-HF/6-31G(d,p) level of theory on **V-Shape** to evaluate the relative energies for the neutral, radical anionic and radical cationic species. Results with inclusion of dichloromethane (IEF-PCM formalism) are shown in Figure S16.

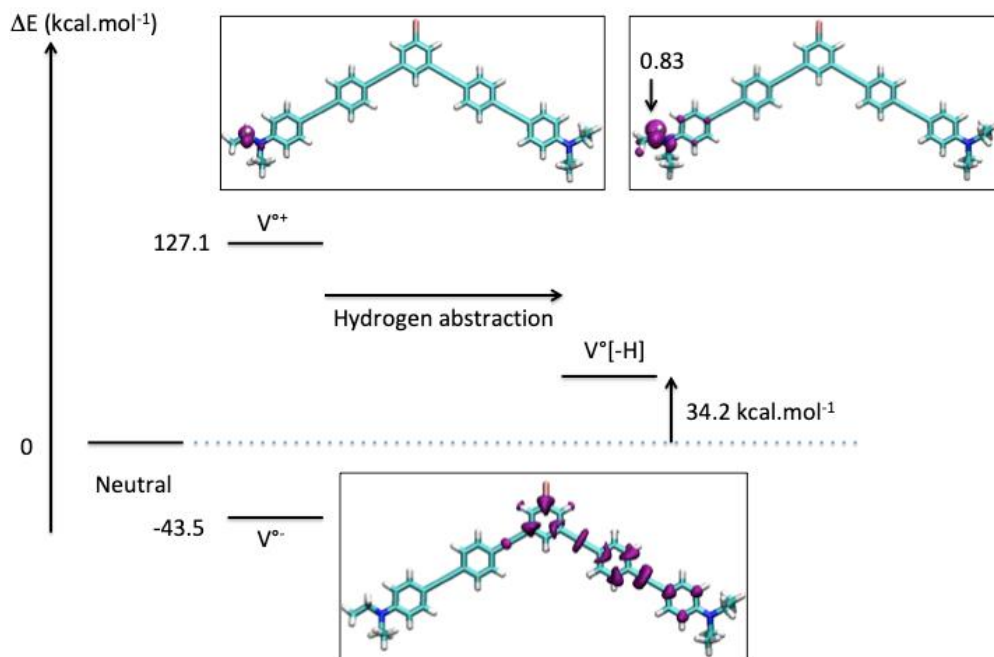


Figure S16. Energies of **V-Shape**, with licorice representations of the stationary point on the potential energy surface. Isodensities are plotted with a contour value of 0.05.

Absolute redox potentials were estimated at 298K, after frequencies calculations according to the computational protocol proposed by Truhlar and coworkers.¹ Frequencies were computed within the harmonic approximation. The difference of redox potentials is estimated to 2.63 V, in neat agreement with the experimental data. The inspection of spin densities indicates a more delocalized, hence more stable, anionic radical compared to the intrinsically unstable cation.

V) Cyclic Voltamperometry

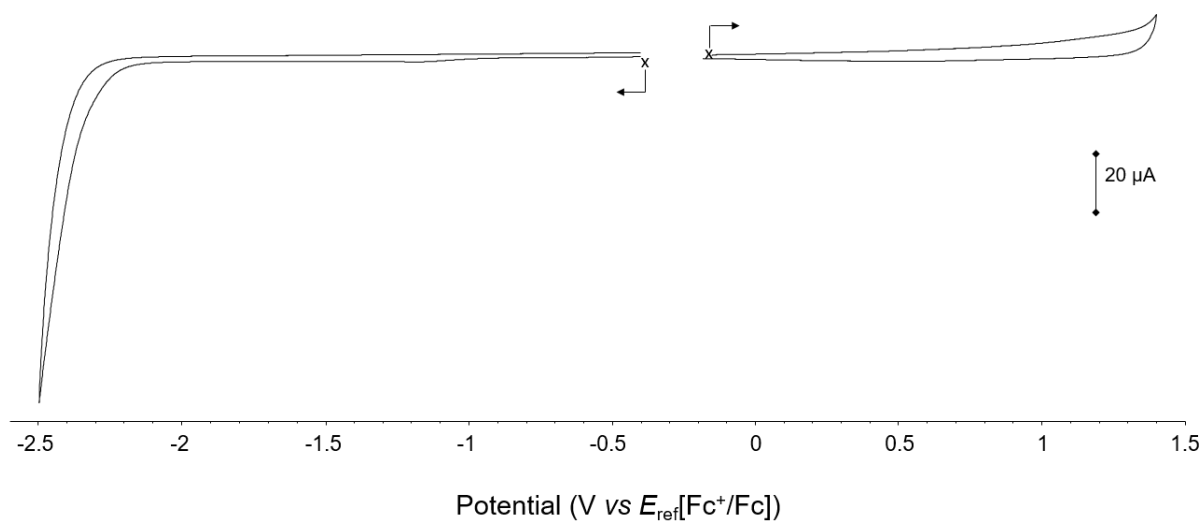


Figure S17. Cyclic voltammogram of DPPHA monomer (1 mmol/L) in dichloromethane in the presence of tetra-*n*-butylammonium perchlorate (0.1 mol/L), $E(V)$ vs. $E_{ref}[Fc/Fc^+]$, at a vitreous carbon working electrode $\varnothing = 3$ mm, 298 K, $\nu = 0.1$ V/s.

VI) Stern-Volmer experiments

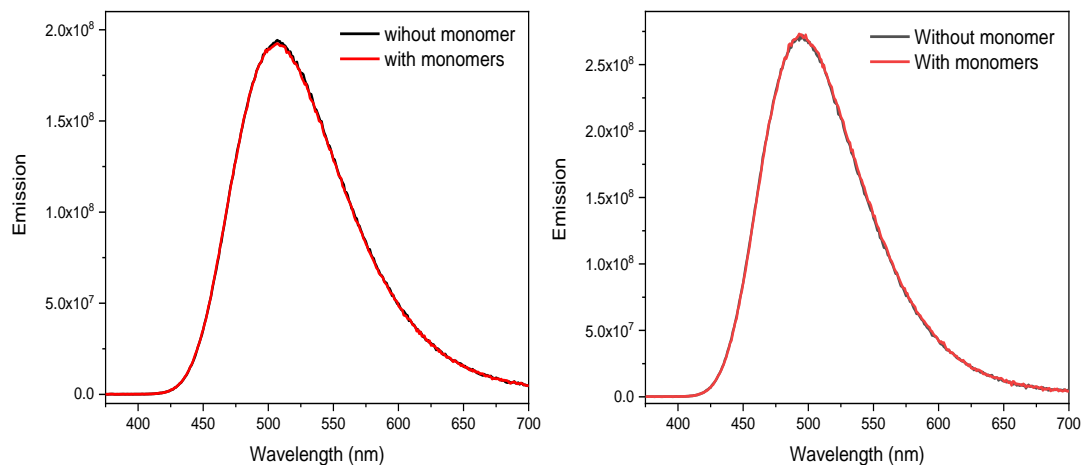


Figure S18. Emission spectra of **V-Shape** (2.66×10^{-6} mol/L, left) and **Oct** (2.08×10^{-6} mol/L, left) with and without DPPHA (4×10^{-3} mol/L). Solvent: dichloromethane, excitation at $\lambda_{ex} = 370$ nm.

VII) Photolysis studies

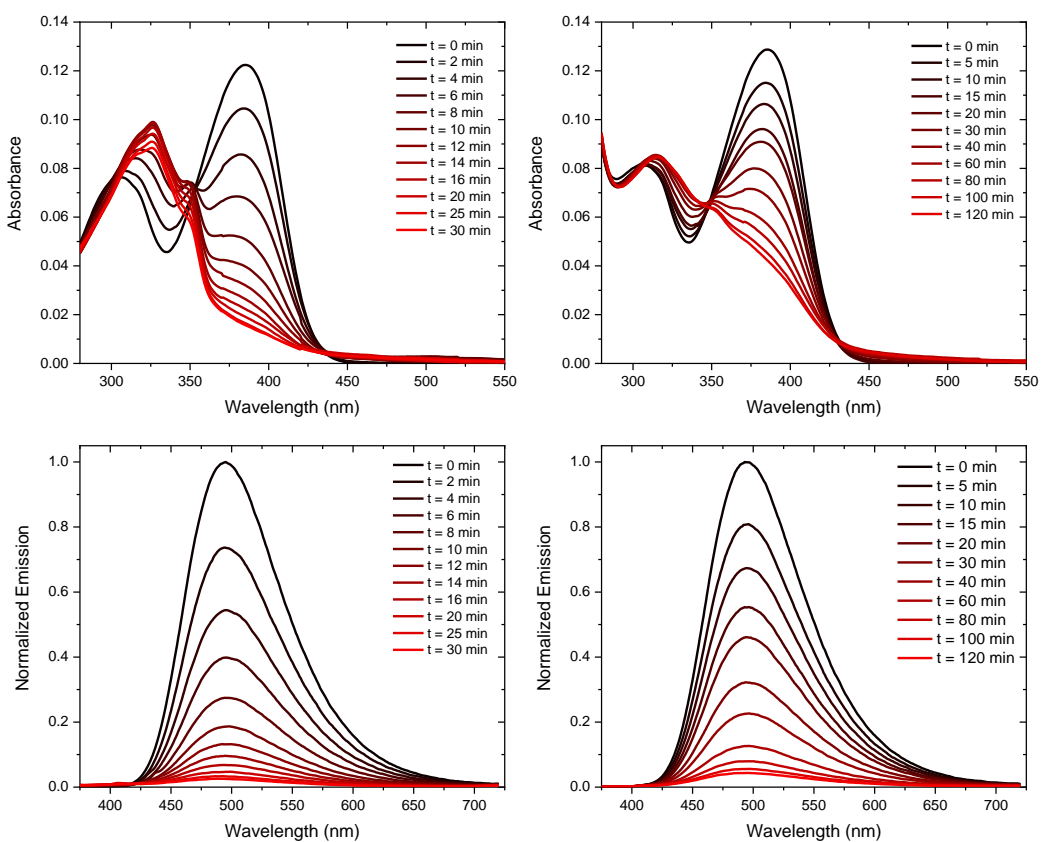


Figure S19. Photolysis studies (UV-Vis and emission) of Oct in degassed dichloromethane under 365 nm irradiation, 40 mW in absence or presence of EA. [Oct] = 8.6×10^{-7} mol/L; [EA] = 0 mol/L (left) and 7×10^{-3} mol/L (right).

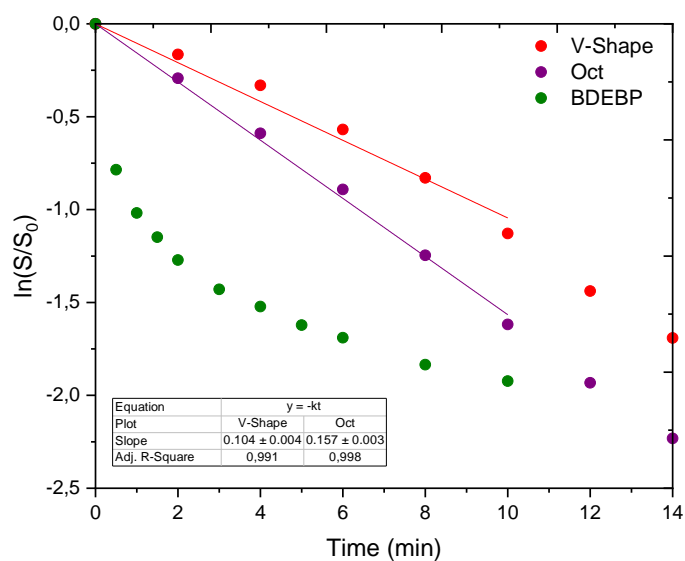


Figure S20. First order reaction fits for the photolysis of **V-Shape** (red), **Oct** (purple) and unfitted scatter for **BDEBP** (green) in degassed dichloromethane under 365 nm irradiation, 40 mW in absence of EA at isoabsorbance concentration at 365 nm with estimated reaction rate constant k . $[V\text{-Shape}] = 1.4 \times 10^{-6} \text{ mol/L}$; $[Oct] = 8.6 \times 10^{-7} \text{ mol/L}$ and $[BDEBP] = 2.6 \times 10^{-6} \text{ mol/L}$.

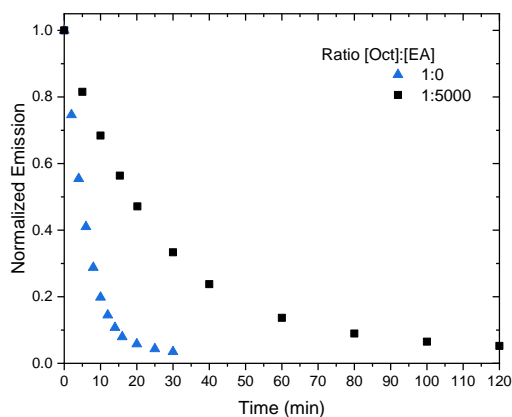


Figure S21. Photolysis of **Oct** in degassed dichloromethane under 365 nm irradiation, 40 mW in absence or presence of EA. $[Oct] = 8.6 \times 10^{-7} \text{ mol/L}$; $[EA] = 0 \text{ mol/L}$ (blue) and $7 \times 10^{-3} \text{ mol/L}$ (black).

VIII) Microfabrication

Python script

A home-made Python script was designed to automatically determine an average value of line widths and heights over a length of several micrometers of the middle of each line. The script proceeds as follows: first, each SEM picture file, such as the one shown in Figure S22a, is converted to a strictly black and white picture by an automatic thresholding operation so that the line on the source image is entirely white and the surrounding becomes black (Figure S22b). The thresholding method used here is Otsu's binarisation. Then, a contour detection function included in the OpenCV library is applied to this modified image to acquire the coordinates of the white pixels (Figure S22c). For control, we can superimpose the shape that has been detected with the original image to ensure that the contour of the line is correct (Figure S22d). Finally, those white pixels can be counted for each row of pixels on the image which allows us to estimate the width of the line along its whole length. The scale bar of each picture is detected and used to convert the number of pixels into a distance measurement. A vertical line anchored to the glass coverslip is shown on Figure S22, but the script is also able to process horizontal lines and suspended lines so that the line height can be evaluated as well.

The error bars correspond to the 95% confidence interval given by the student's t-distribution. Thus, it provides information on the error resulting from the measurement of the line widths and heights by SEM. The values were considered without subtracting the thickness of the platinum layer (expected at 10 nm).



Figure S22. Description of the different steps of the Python script: a) the original image; b) the same image after thresholding; c) the plot of white pixel coordinates; d) the detected contour is shown in red and the average width and the associated error is indicated in green on the final picture.

Evolution of the line widths and heights versus laser power

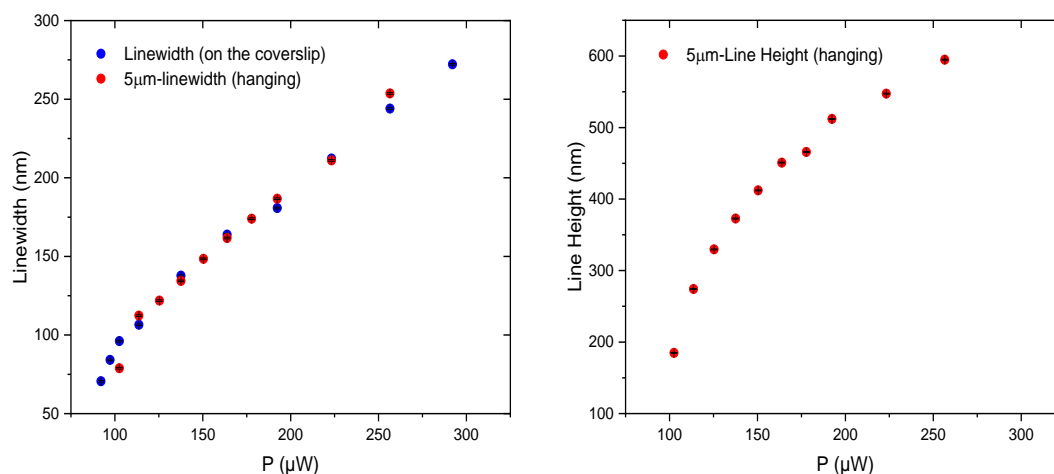


Figure S23. Evolution of the line width (left) and height (right) versus laser power used during the fabrication. The blue dots correspond to structures fabricated at the surface of the coverslip and the red ones correspond to lines suspended between two supports. Writing speed 40 μm/s, photoresist: DPPHA:DDA:V-Shape (79.2:19.8:1).

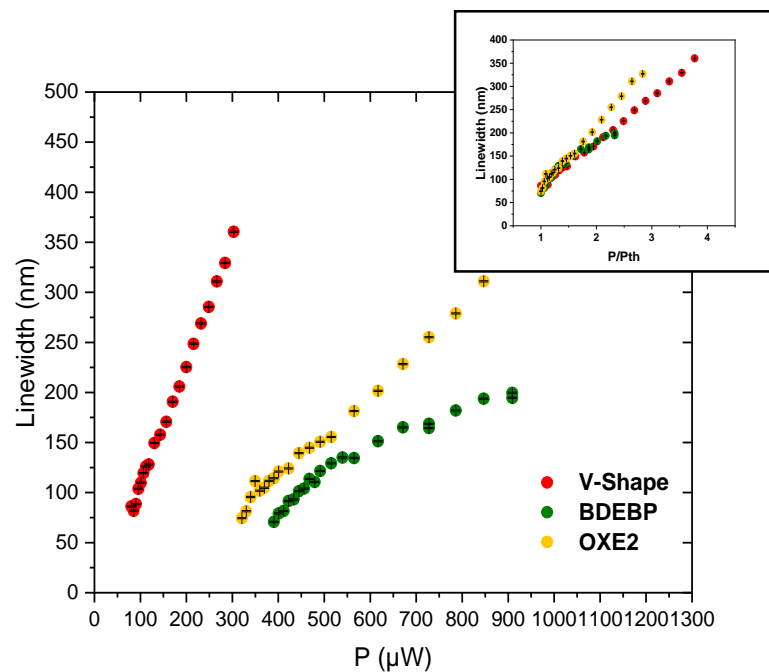
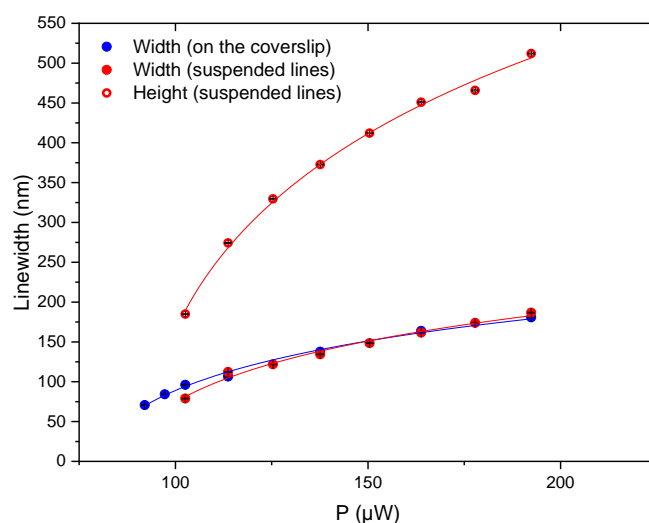


Figure S24. Linewidth versus average laser power (major graph) and ratio average power/threshold power (inset) for three photoresists based on a mixture of DPPHA/DDA (80/20) with $10.9\mu\text{mol/g}$ V-Shape (red), BDEBP (green) and OXE2 (yellow).

Modeling of the evolution of the line widths and heights



Equation	$w \cdot \sqrt{2 \cdot \ln(x/Pth)}$		
Plot	Width (on the coverslip)	Width (suspended)	Height (suspended)
w (nm)	136 ± 3	146 ± 3	419 ± 5
Pth (μW)	81 ± 1	88 ± 2	93 ± 1
Adj. R ²	0.994	0.986	0.996

Figure S25. Modeling of the evolution of the line width and height versus laser power following equation 3. Writing speed 40 μm/s, photoresist: DPPHA:DDA:V-Shape (79.2:19.8:1). w corresponds to w_{xy} , the beam waist in the x-y plane for the two first columns and to w_z , the beam waist along the z-axis for the last one.

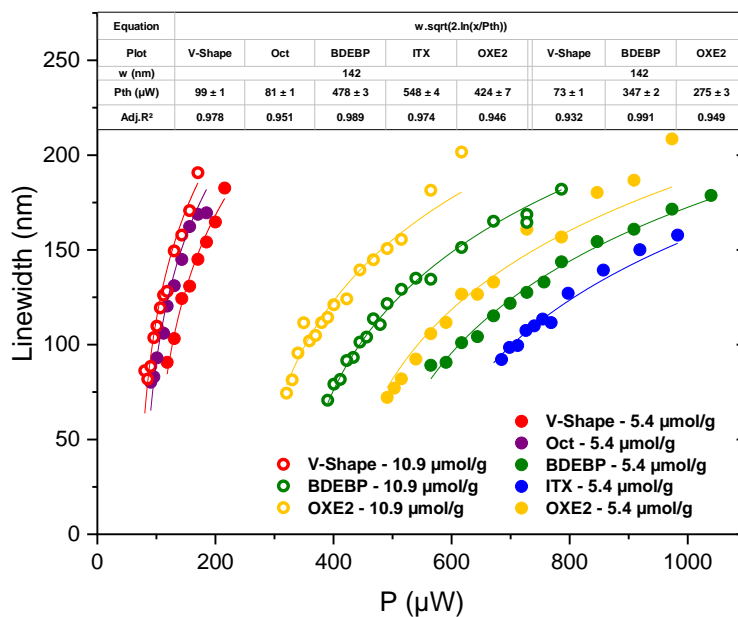


Figure S26. Modeling of the evolution of the line width versus laser power following equation 3. Writing speed 40 μm/s. The photoresists are based on a mixture of DPPHA/DDA (80/20) with two different concentrations of the five PIs used in this study.